### 502261097 03/11/2013

# PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
Seiichi SATO	01/22/2013
Mari MIYANO	01/30/2013
Shigeki ENDO	02/21/2013
Osamu SHIINO	02/01/2013
Shingo ONO	01/30/2013
Masato YOSHIKAWA	02/21/2013

#### **RECEIVING PARTY DATA**

Name:	BRIDGESTONE CORPORATION	
Street Address:	10-1, Kyobashi 1-chome	
City:	Chuo-ku, Tokyo	
State/Country:	JAPAN	
Postal Code:	104-8340	

#### PROPERTY NUMBERS Total: 1

Property Type	Number	
Application Number:	13821603	

# **CORRESPONDENCE DATA**

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PATENT REEL: 029961 FRAME: 0884 \$40.00 1382

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NAME OF SUBMITTER:	Alexander E. Auerbach, New App. Spec.
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PATENT REEL: 029961 FRAME: 0885

3-03-05:03:25PM: SUGHRUEMION PLLC : # 47
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For	Non-U.S.	Clients

# Assignment

Whereas, I/We, (1) Sciichi SATO of Hvogo, Japan, (2) Mari MIYANO of Tokyo, Japan, (3) Shigeki ENDO of Saitama, Japan, (4) Osamu SHIINO of Tokyo, Japan, (5) Shingo ONO of Tokyo, Japan, (6) Masato YOSHIKAWA of Tokyo, Japan hereinafter called assignor(s), have invented certain improvements in METHOD FOR PRODUCING SILICON FINE PARTICLES AND METHOD FOR CONTROLLING PARTICLE DIAMETER OF SILICON FINE PARTICLES and executed an application for Letters Patent of the United States of America therefor on \_\_\_\_\_; and

Whereas,

**BRIDGESTONE CORPORATION** 

10-1, Kyobashi 1-chome, Chuo-ku,

Tokyo 104-8340 Japan

(assignee), desires to acquire the entire right, title, and interest in the application and invention, and to any United States patents to be obtained therefor;

Now therefore, for valuable consideration, receipt whereof is hereby acknowledged,

I/We, the above named assignor(s), hereby sell, assign and transfer to the above named assignee, its successors and assigns, the entire right, title and interest in the application and the invention disclosed therein for the United States of America, including the right to claim priority under 35 U.S.C. §119, and I/we request the Director of the U.S. Patent and Trademark Office to issue any Letters Patent granted upon the invention set forth in the application to the assignee, its successors and assigns; and I/we will execute without further consideration all papers deemed necessary by the assignee in connection with the United States application when called upon to do so by the assignee.

I/We hereby authorize and request our attorneys SUGHRUE MION, PLLC of 2100 Pennsylvania Avenue, NW, Washington, DC 20037-3213 to insert here in parentheses (Application number 13/821,603 and Confirmation number 6554 filed on 2013-03-08) the application number and filing date of said application when known.

Date: Jan 22, 2013

Sciichi SAT

Date: Oak

Jan. 30, 2013

Man Miyma

Mari MIYANO

Date:

Feb. 21. 2013

Shinali VA

Date:

Feb. 1, 2013

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Osamu SHIINO

Jan . 30 . 2013 Date:

Date:

Fab. 21.2013

(Legalization not required for recording but is prima facie evidence of execution under 35 U.S.C. §261)

**PATENT** 

**REEL: 029961 FRAME: 0887**